



501.42786X00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: CHENG et al

Serial No.: 10/620,702

Filed: July 17, 2003

For: Inspection Method And Apparatus For Circuit Pattern

Art Unit: 2829

Examiner: P. Patel

AMENDMENT

Mail Stop: Amendment (Fee)
Commissioner For Patents
P.O. Box 1450
Alexandria, VA 22313-1450

February 22, 2005

Sir:

The following amendments and remarks are respectfully submitted in connection with the above-identified application, in response to the Office Action dated October 20, 2004. The amendments are listed below and set forth on the following pages.

Amendments to the Title; and

Remarks are included following the amendments.